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## **CONFIRMATION NO. 4772**

SERIAL NUMBE 10/691,108	FILING DATE 10/22/2003 RULE	CLASS 216	GROUP ART 1765	T UNIT	ATTORNEY DOCKET NO. 10191/3399		
APPLICANTS							
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** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/22/2004							
Foreign Priority claimed 35 USC 119 (a-d) condition	yes ons	STATE OR	SHEETS	TOTAL	INDEPENDENT		
met Verified and Acknowledged	Allowance	COUNTRY GERMANY	DRAWING 9	CLAIMS 5	CLAIMS 4		
ADDRESS 26646 KENYON & KENYON ONE BROADWAY NEW YORK, NY 10004							
TITLE Device and method for anisotropic plasma etching of a substrate, particularly a silicon element							
			☐ All Fees				
FILING FEE FE	ES: Authority has been given in Paper  b to charge/credit DEPOSIT ACCOUNT			1.16 Fees (Filing)			
RECEIVED No. 986	o for following	for following:			☐ 1.17 Fees ( Processing Ext. of time )		
					1.18 Fees (Issue)		